



Physikalisch-Technische Bundesanstalt
Braunschweig and Berlin
National Metrology Institute

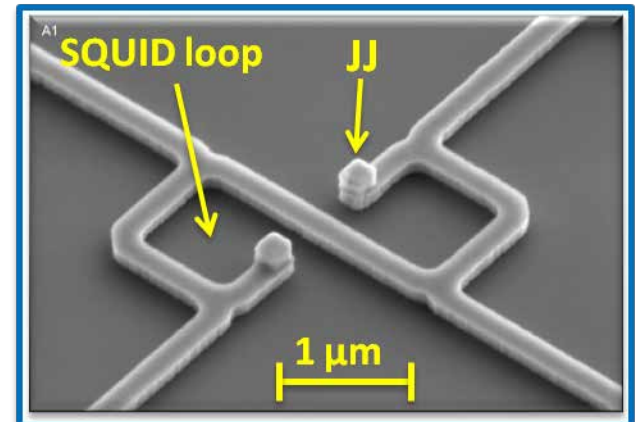
HfTi-nanoSQUIDs for nanoscale magnetic detection

PTB Berlin

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Thomas Schurig

PTB Braunschweig

Oliver Kieler, Johannes Kohlmann, and
Thomas Weimann



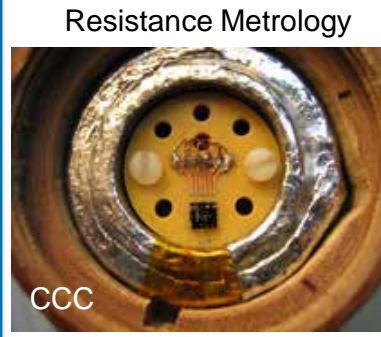
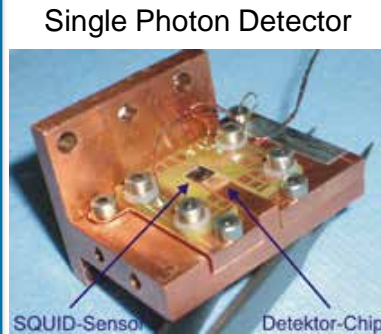


SQUID – Applications at PTB

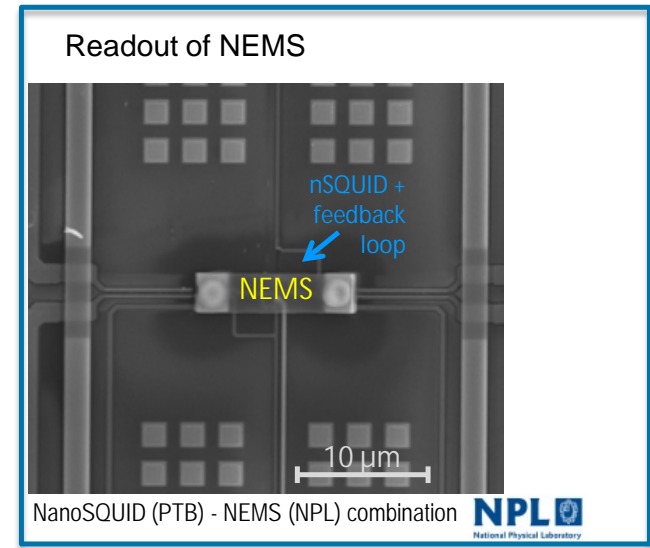
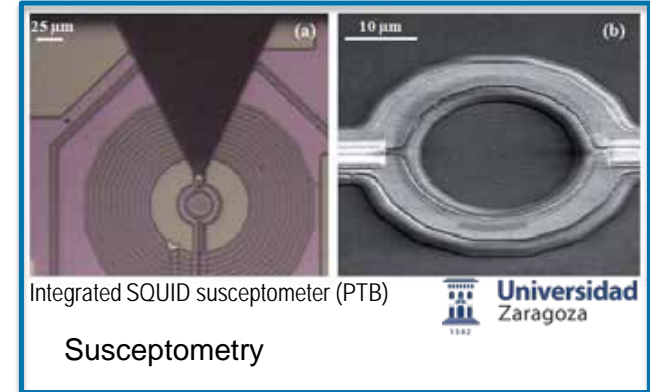
Biomedical Analytical Methods



Metrology



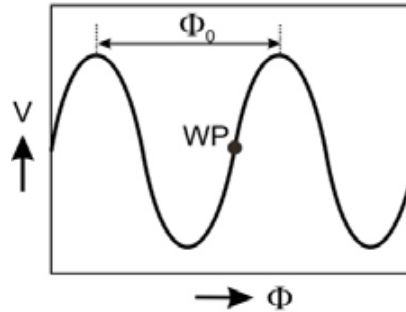
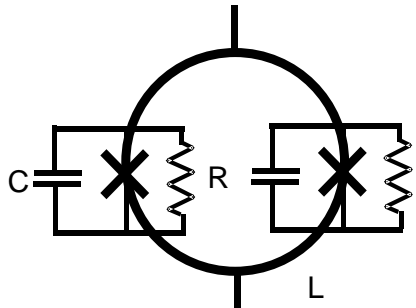
Material Characterization



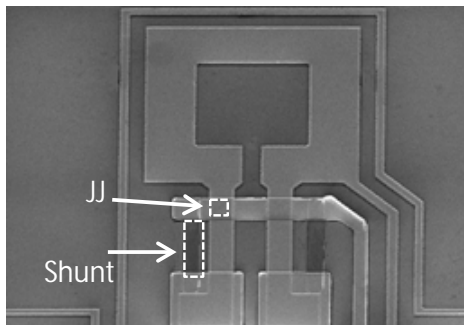


Dc SQUIDS

dc SQUID



- C junction capacitance
- L SQUID loop inductance
- R resistance
- F magnetic flux
- F_0 flux quantum
- V voltage
- WP working point



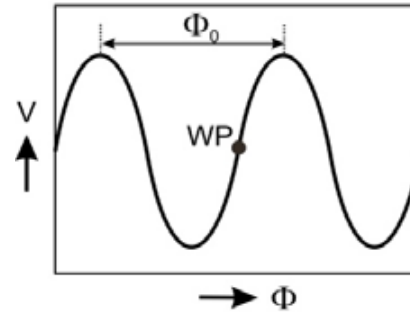
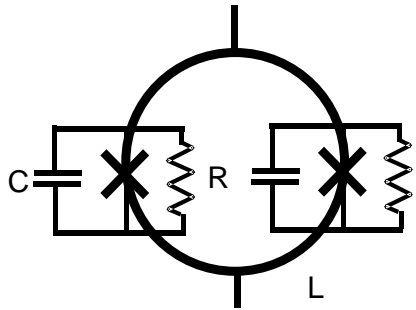
Washer SQUID with SIS junctions
(Nb/AlO_x/Nb)

Periodic flux-to-voltage characteristic.

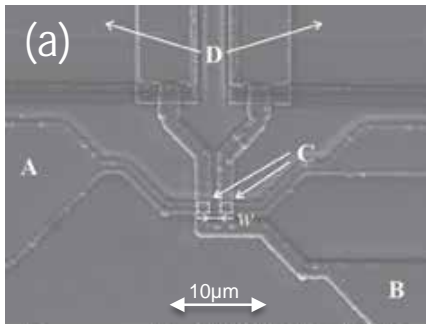


Dc SQUIDS

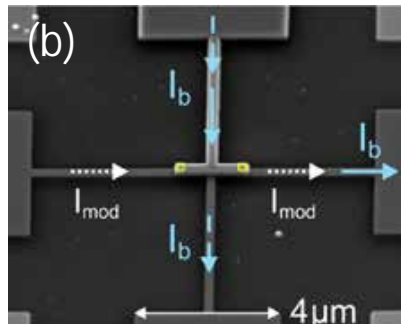
dc SQUID



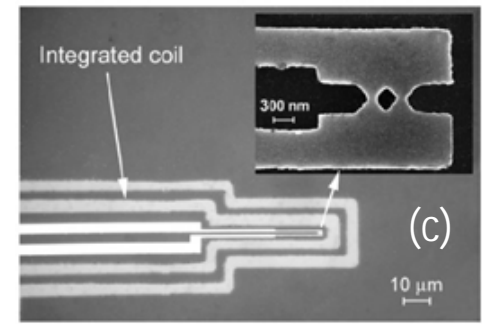
- C junction capacitance
- L SQUID loop inductance
- R resistance
- F magnetic flux
- F_0 flux quantum
- V voltage
- WP working point



Washer SQUID with cross-type SIS junctions (Nb/AlOx/Nb),
 M. Schmelz et al., Appl. Phys. Lett. 102, 192601 (2015)



SQUID with SNS junctions (Nb/HfTi/Nb),
 microstrip geometry,
 R. Wölbing et al., Appl. Phys. Lett. 102, 192601 (2013)



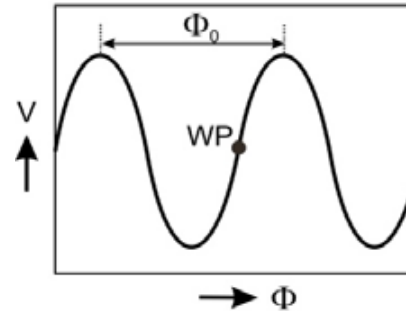
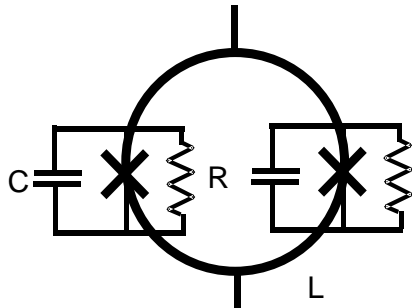
SQUID with constriction junctions,
 Nb/Al bilayer
 C. Granata et al, Nature Nanotechnol. 19, 275501 (2006)

Periodic flux-to-voltage characteristic.



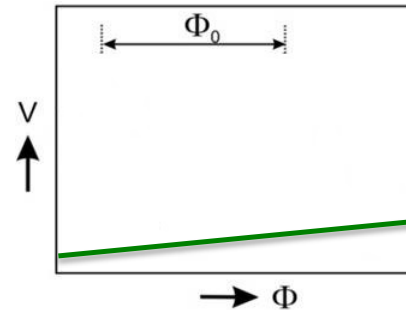
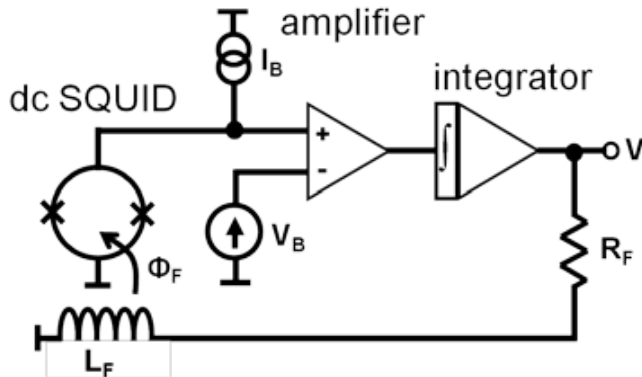
Dc SQUID Readout

dc SQUID



- C junction capacitance
- L SQUID loop inductance
- F magnetic flux
- F_0 flux quantum
- V voltage
- V_B bias voltage
- I_B bias current
- R_F feedback resistor
- F_F feedback flux
- WP working point

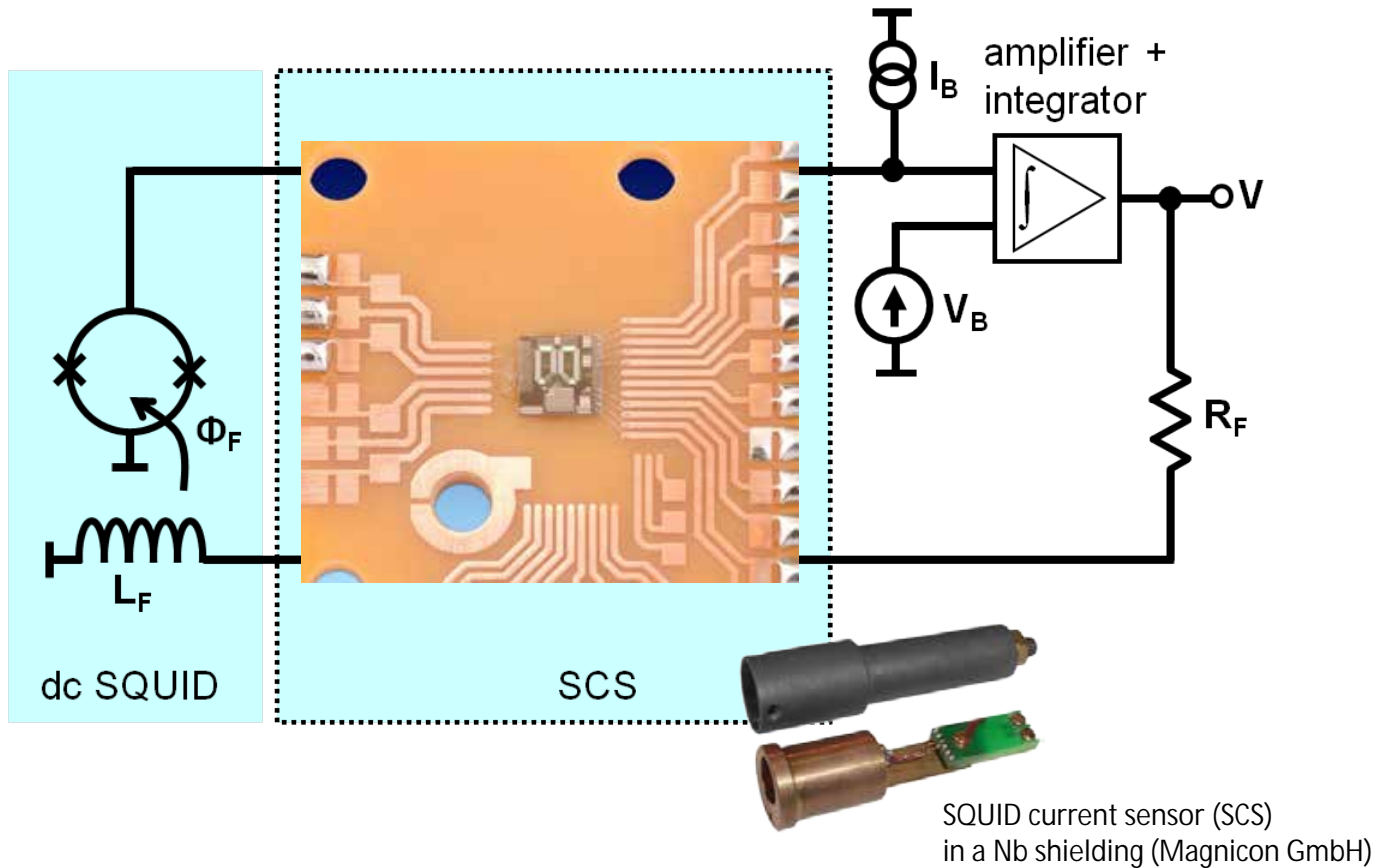
Flux-locked loop (FLL) operation



WP is kept stable on the periodic flux-to-voltage characteristic.

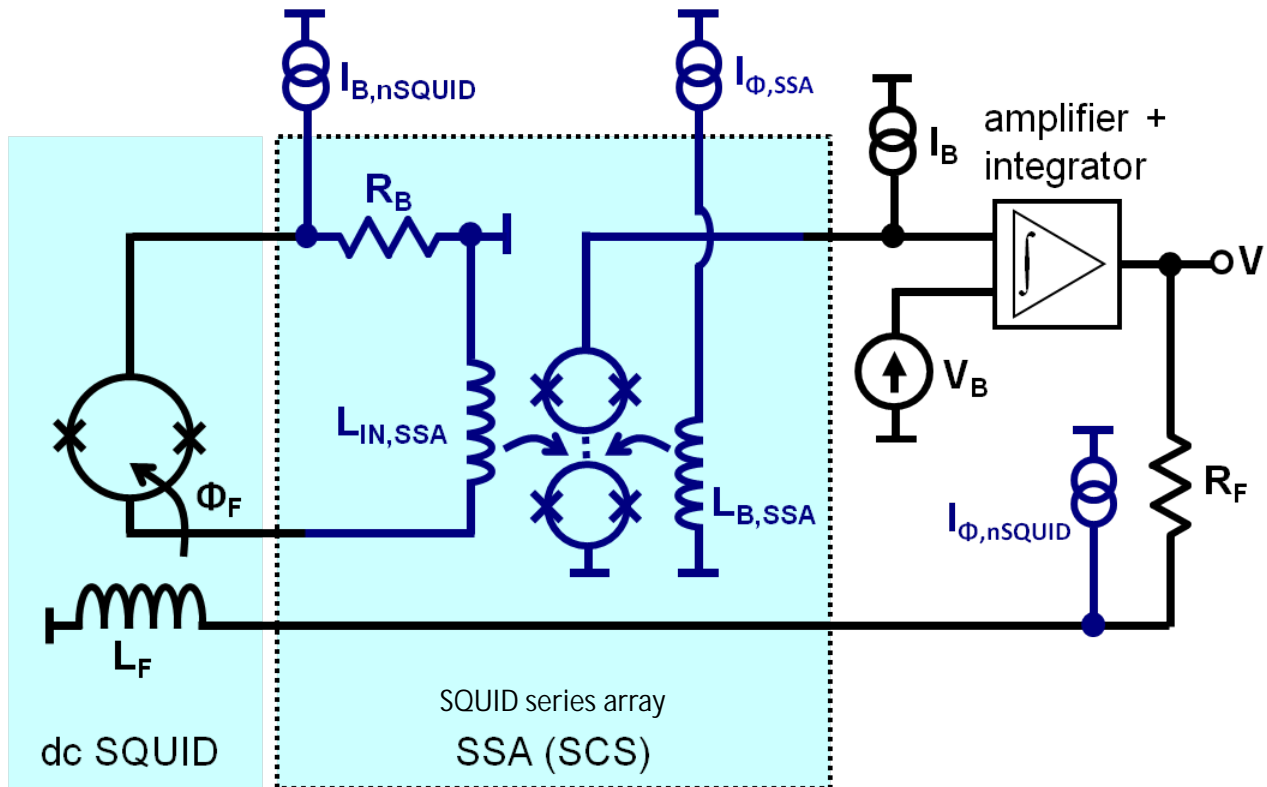


Dc SQUID Readout





2-stage Readout





Demands for High Energy Resolution



$$\epsilon = S_{\Phi} / (2L)$$

$$S_{\Phi} \approx 2L * 16k_B T * (LC)^{1/2}$$

- efficiency ~ coupling or filling factor
 - small dimensions → lower **SQUID inductance** + **junction capacitance**
- high energy resolution → low and ultra-low **temperatures**
- high dynamic range
- high tolerance against applied magnetic field





Nb/HfTi/Nb-NanoSQUIDs

Josephson junctions:

Intrinsically shunted SNS Junctions with HfTi

Nominal lateral size: ca. 200nm x 200nm (180nm/220nm/240nm/260nm)

Nominal barrier thickness: 30nm

Distance between JJs: $\leq 1\mu\text{m}$

Design: PTB Berlin

Fabrication: PTB Braunschweig

SQUID Sensors:

§ SQUID gradiometers

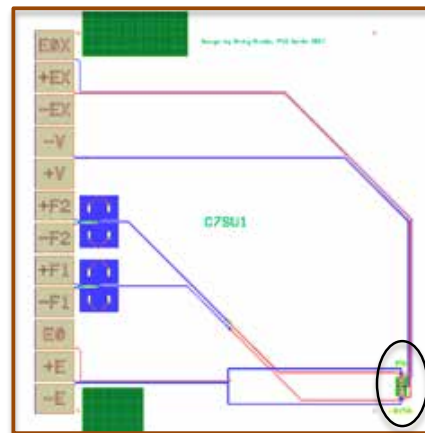
§ SQUID current sensors

Complements:

§ feedback

§ rf filter

§ 3 (4) different transformers

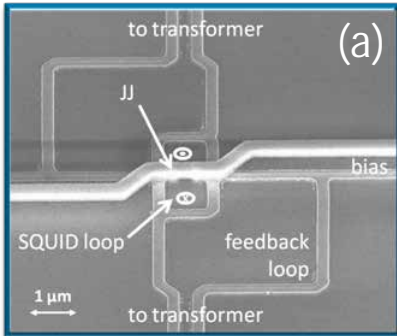


nSQUID with transformers

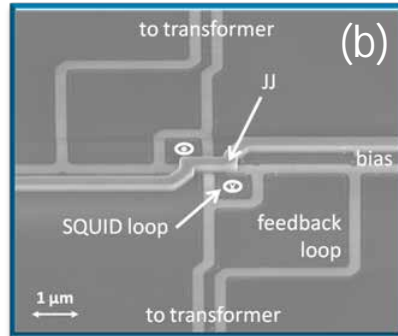
Chip
3mm x 3mm



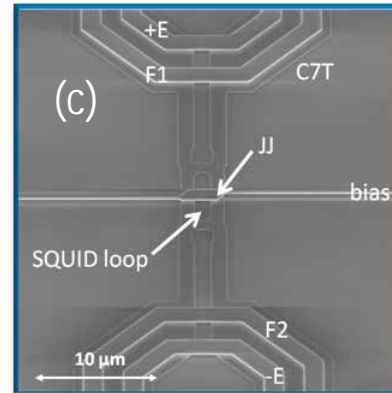
Device Family



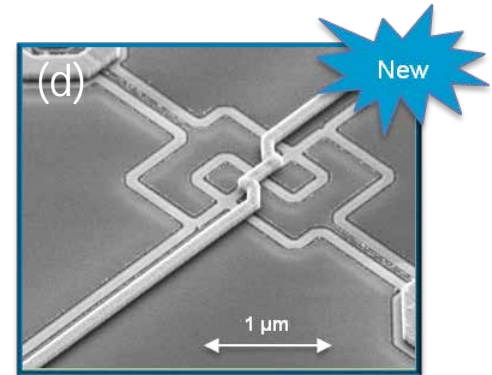
nSQUID parallel gradiometer



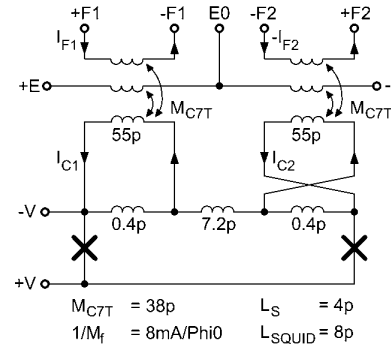
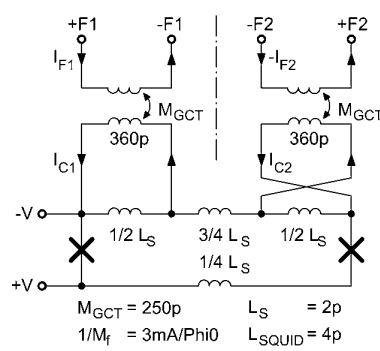
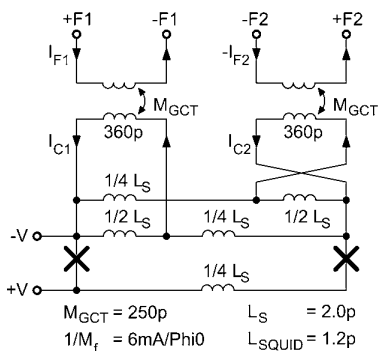
nSQUID series gradiometer



μSQUID series gradiometer



nSQUID current sensor

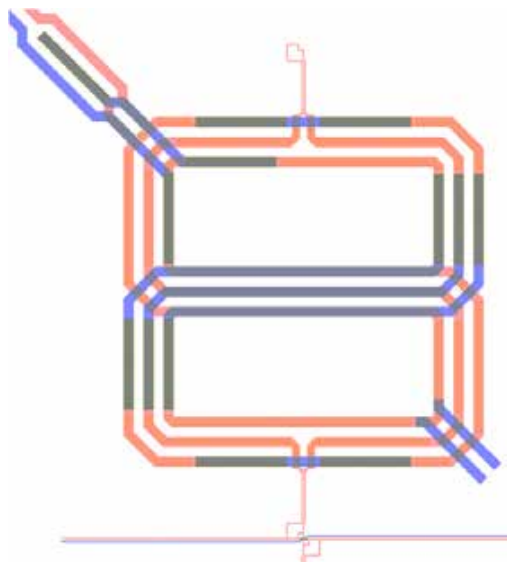


S. Bechstein et al., „HfTi-nanoSQUID gradiometers with high linearity,“
Applied Physics Letters 106, 072601 (2015); doi: 10.1063/1.4909523



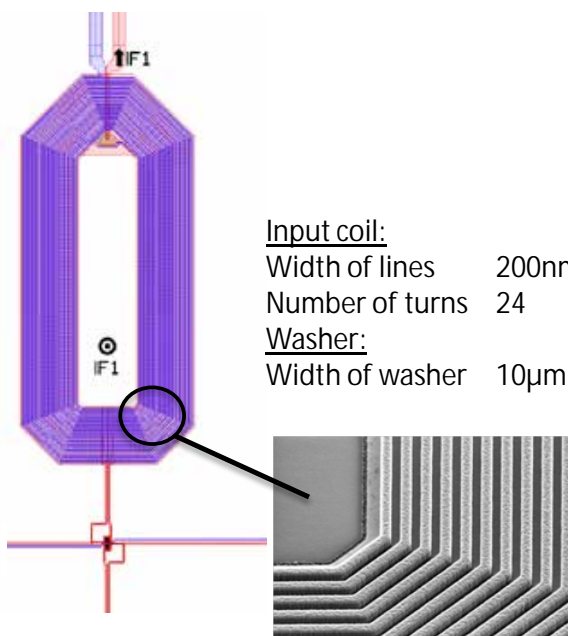
Transformers of Gradiometers

Gradiometric Coupling Transformer (GCT)



Width of lines 2 μ m
Thickness of Nb layer 200nm

Bias Reversal Transformer (BRT)



Input coil:
Width of lines 200nm
Number of turns 24
Washer:
Width of washer 10 μ m

C7 Transformer (C7T)



Width of lines 1.5 μ m
Width of washer 8 μ m



Fabrication



- § Clean room center Braunschweig
- § Electron beam lithography
- § Chemical mechanical polishing process (CMP)
- § Supporting structures consisting of Nb1 and HfTi integrated in design
 - § homogeneous polished junctions
 - § negligible small changes of I_c across the wafer area
 - § protecting isolation @ bridges (e.g. filters)



Clean room center (PTB Braunschweig).

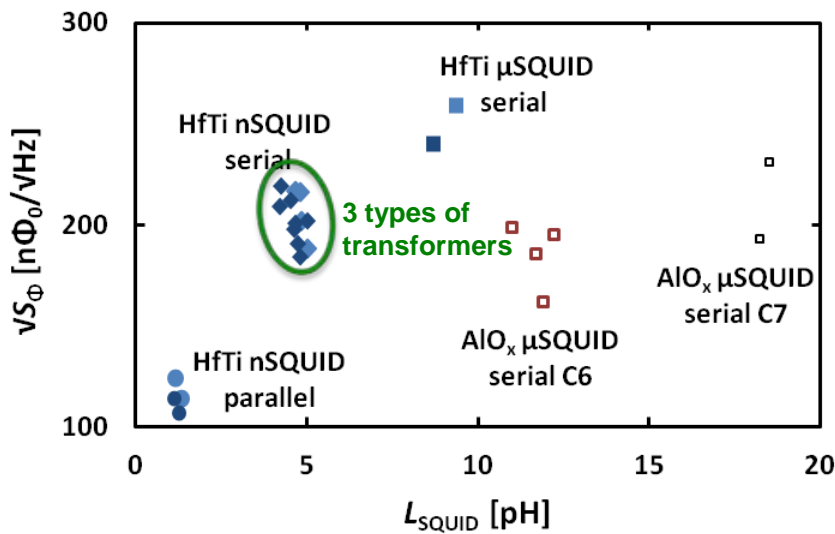
high rate of yield



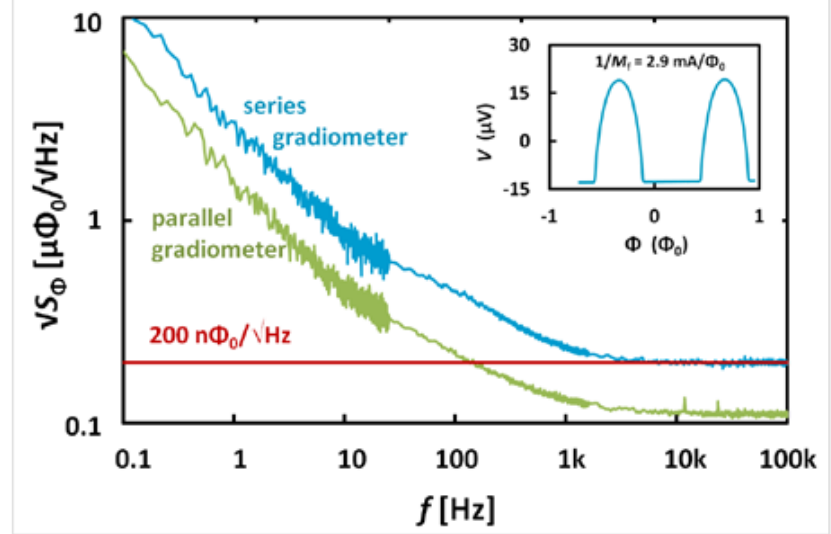
Inductance and Flux Noise

Setup: 2-stage configuration with SSA, FLL mode

Magnetic flux noise @ 20kHz ... 50kHz



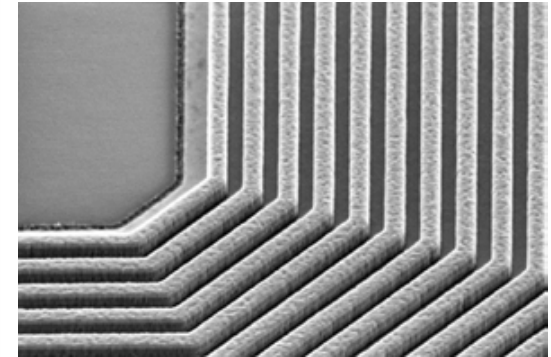
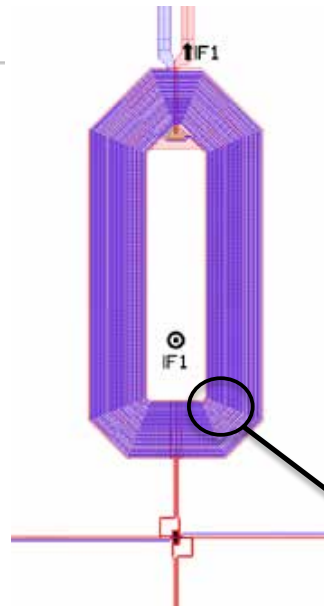
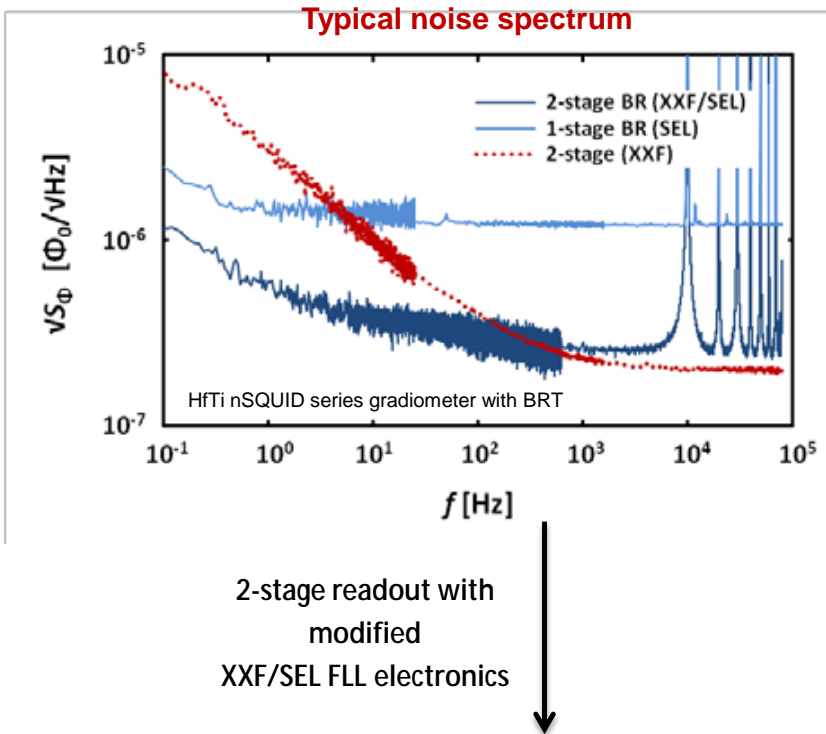
Noise spectra



magnetic flux noise independent on type of transformer
110 nΦ₀/√Hz achievable



Low-Frequency Flux Noise



Section of Bias Reversal Transformer (BRT).
Width of lines: 200nm, number of turns: 24.

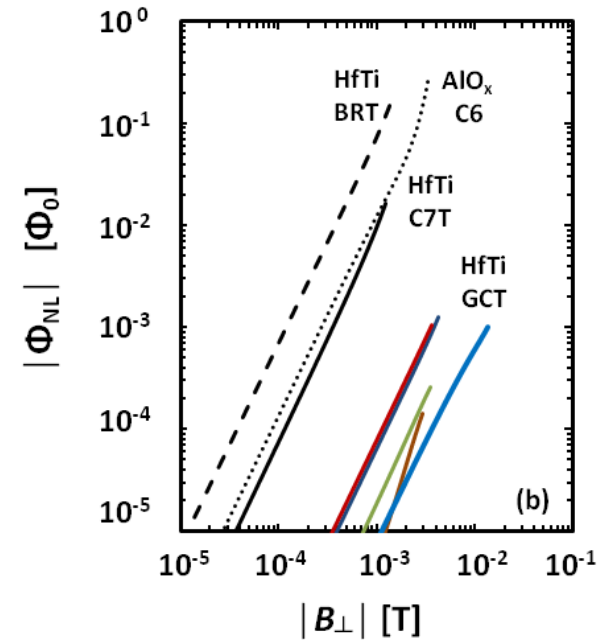
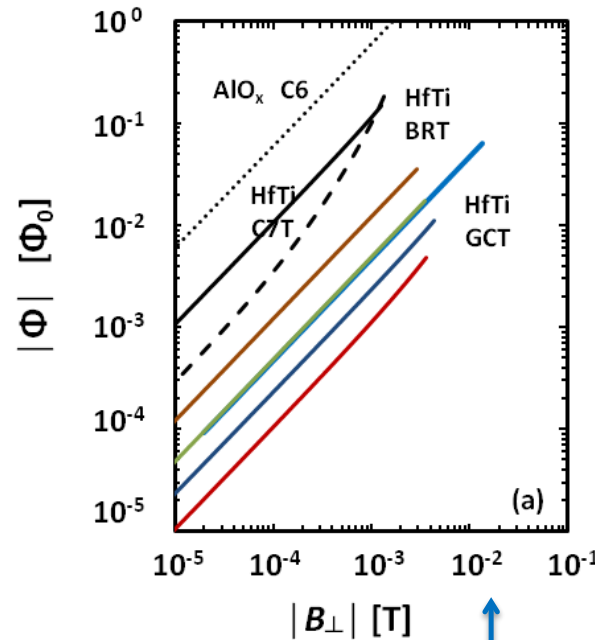
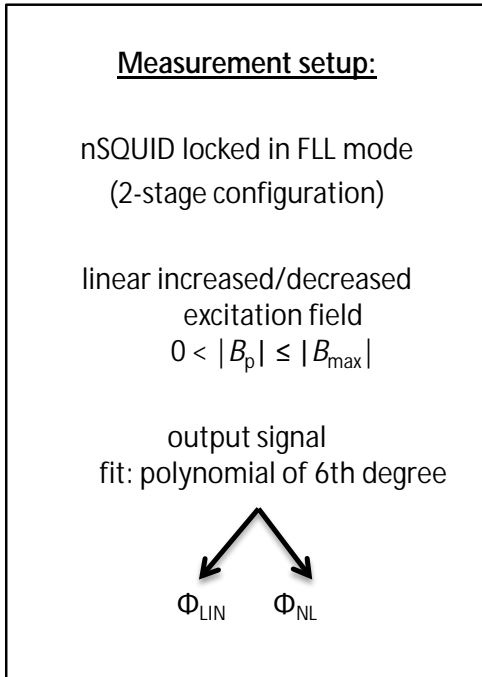
low-frequency noise reduced with bias reversal in 2-stage configuration
à source: fluctuations (I_c , R)

S. Bechstein et al., „HfTi-nanoSQUID gradiometers with high linearity,“
Applied Physics Letters 106, 072601 (2015); doi: 10.1063/1.4909523



Susceptometer Application

Setup: 2-stage configuration with SSA, FLL mode



Improved design: $B_{max, GCT} \approx 15mT$

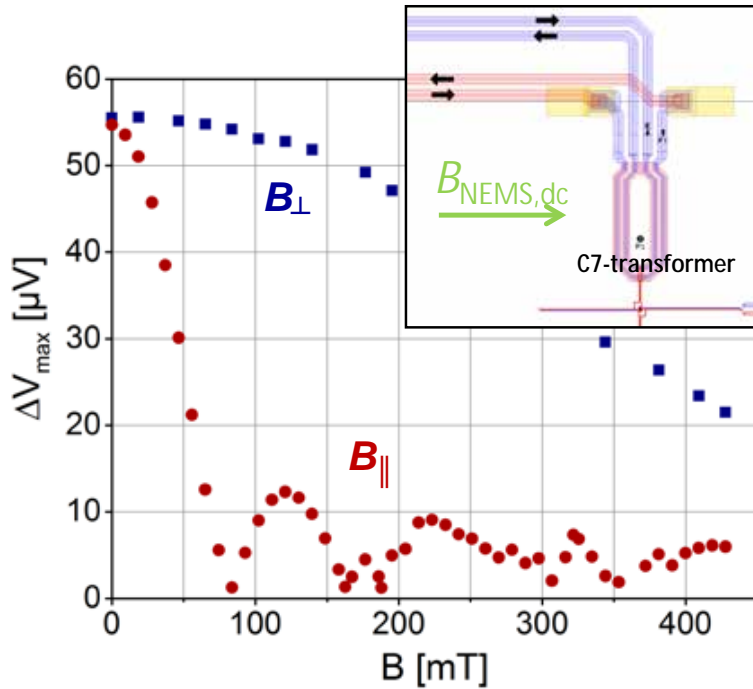
HfTi-nanoSQUID gradiometers with GCT: linear (a) and nonlinear (b) part very low

suitable for susceptometer applications J

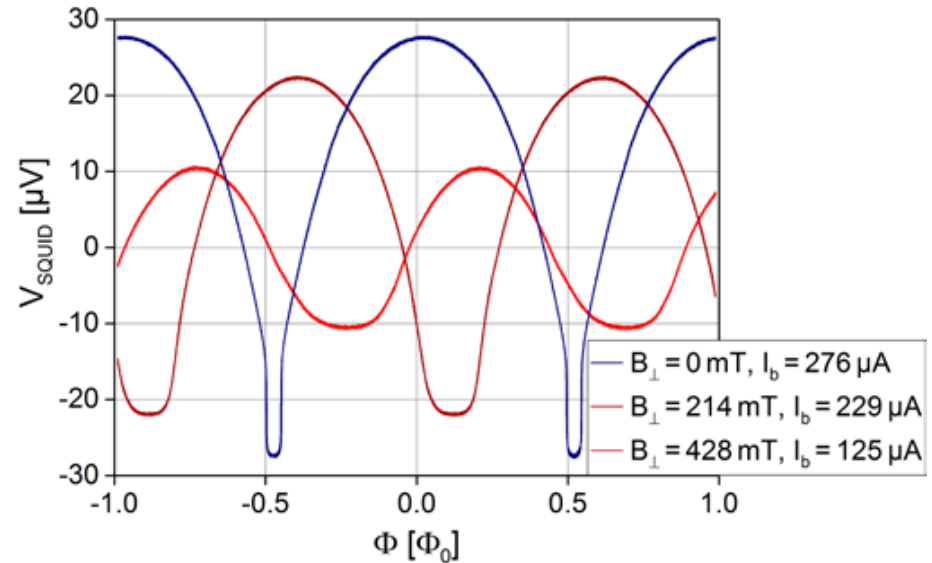


NEMS Application

Setup: 1-stage configuration, AMP mode



Maximum voltage swing of a nanoSQUID series gradiometer with C7-transformer versus dc magnetic field.



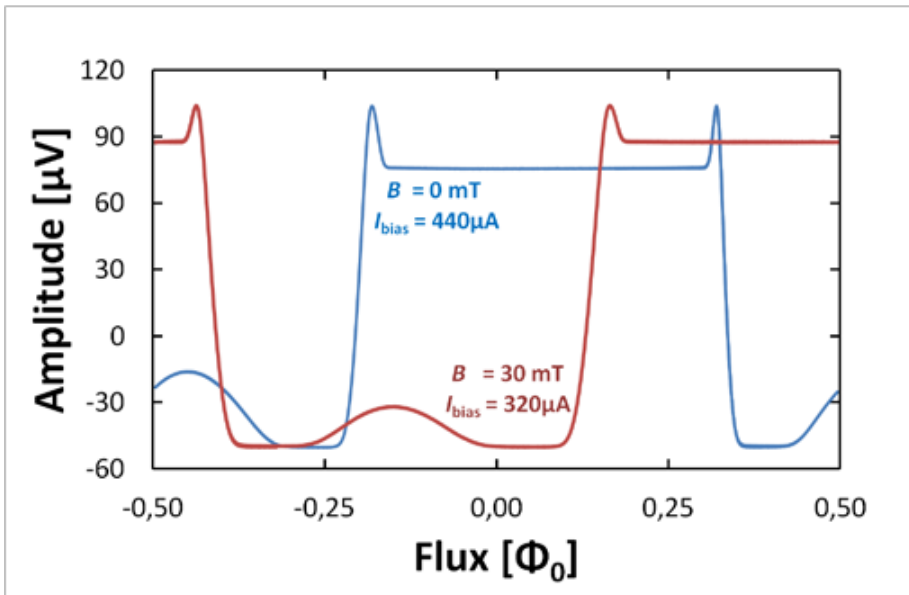
Voltage across the nanoSQUID series gradiometer versus magnetic flux (perpendicular to the SQUID loop).

suitable for NEMS readout J

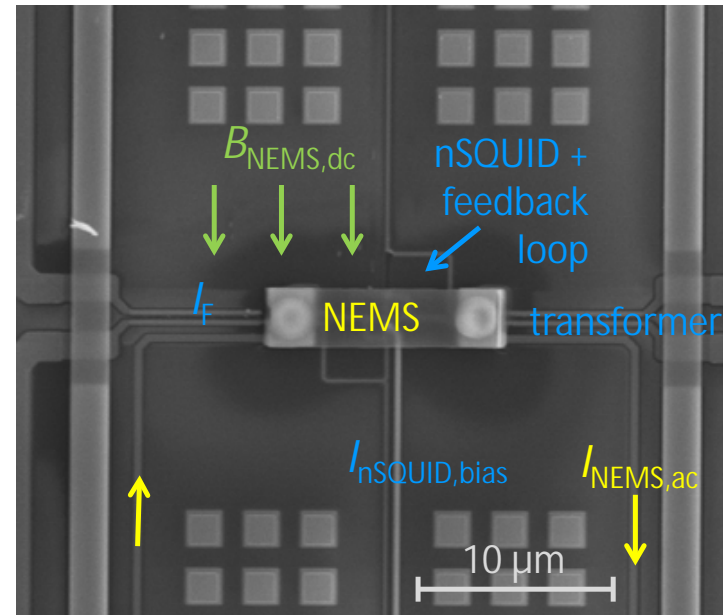


NEMS Application

Setup: 2-stage configuration with SSA, AMP mode



Voltage of a nanoSQUID series gradiometer with GCT/SSA combination versus magnetic flux.



Section of a combination of a nanoSQUID series gradiometer with GCT and NEMS (cooperation with NPL).

suitable for NEMS readout J

Summary / Outlook

Milestone: new family of HfTi-nanoSQUID sensors

- § technology well established
- § complex sensors
gradiometers and current sensors with transformers, feedback circuitry, rf filters
- § low level of nonlinearity → susceptometer application
- § field tolerance of at least a few mT up to a few 100mT → NEMS readout
depending on operation and type of transformer

Outlook:

- § design
 - § further improvement of field tolerance, smaller structures (transformers)
 - § further adaption to each application (further specialization)
- § measurements
 - § susceptometer measurements together with partners
(nano particles, molecules, single spin detection)
 - § NEMS readout

Thank you:

Corinna Neubauer
Frank Ruede
Lars Schikowski
Kathrin Störr



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